

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

DT04 Rec'd PCT/PTO 15 OCT 2004

Applicant(s): Dietrich Mund and Jürgen Leib
Serial No.: Not Yet Assigned
Filed: Herewith
For: PROCESS FOR COATING METAL SURFACES, AND
SUBSTRATE WITH A COATED METAL SURFACE
Art Unit: Not Yet Assigned
Examiner: Not Yet Assigned
Confirmation No.: Not Yet Assigned
Customer No.: 27623

Attorney Docket No.: 2133.061USU

Date: October 15, 2004

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

In accordance with applicants' duty of disclosure under 37 C.F.R. §1.56, we are enclosing form PTO-1449 listing information that may be material to the patentability of this application.

It should be understood that attention has been called to the citations that have been deemed to be pertinent to the claimed present invention. In concluding what was pertinent, the criteria employed was considered most appropriate in light of the invention shown in the present application. However, the Examiner or others may deem some other criteria to be just as appropriate or more appropriate. Therefore, the

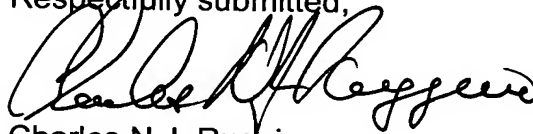
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Examiner is respectfully urged to review the listed citations and to make the usual careful independent search for other prior art that may be pertinent.

Since this Information Disclosure Statement is being filed with the filing of this application, no petition or fee is required.

Applicants respectfully request favorable consideration and that this application be passed to allowance.

Respectfully submitted,



Charles N.J. Ruggiero

Reg. No. 28,468

Attorney for Applicant(s)

Ohlandt, Greeley, Ruggiero & Perle, L.L.P.

One Landmark Square, 10th Floor

Stamford, CT 06901-2682

(203) 327-4500

CUSTOMER NO.: 27623

FORM PTO-1449

Docket Number (Optional)

2133.061USU

Application Number

Not Yet Assigned

INFORMATION DISCLOSURE CITATION
IN AN APPLICATION

Applicant

Mund and Leib

Filing Date

Herewith

Group Art Unit

Not Yet Assigned

(Use several sheets if necessary)

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	4,104,418	8/1/78	Park et al.	427	42	
	4,737,252	4/12/88	Hoffman	204	192.16	

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
	DE10222609.1A1	5/23/02	Germany				X
	DE10222958.9A1	5/23/02	Germany				X
	DE10222964.3A1	5/23/02	Germany				X
	DE10252787.3A1	11/13/02	Germany				X
	DE10301559.0A1	10/30/03	Germany				X
	387175	5/15/65	Switzerland				X

OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, Etc.)

	XP-000819426, Sputtered Lead Silicate Glass Film for Multilevel Interconnections, Kato et al., 2419 Japanese Journal of Applied Physics Supplements, vol. 22 (1983) suppl. No. 22-1, Tokyo, Japan, pgs 167-170
	XP-002251599, Eliminating The Step in Etched via Holes Interrupted Sputter Glass Deposition, Bialko et al., vol. 20, no. 7 (1977), IBM Technical Disclosure Bulletin, pg 26.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP §609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to the applicant.